## Notice of References Cited Application/Control No. 10/795,965 Examiner Thanh Lam Applicant(s)/Patent Under Reexamination HE, LEI Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2004/0063536 A1	04-2004	Atarashi, Hirofumi	477/003
	В	US-		,	
	С	US-			
	D	US-			
	Е	US-			
	F	US-			·
	G	US-			
	Н	US-			
	I	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-	,		

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ņ					
	0					
	Р					
	Q					
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
	U							
	v							
	w	·						
	x							

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.